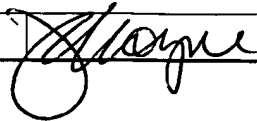


## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

I hereby certify that this transmittal of the below described document is being deposited with the United States Postal Service in an envelope bearing First Class Postage and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the below date of deposit.			
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In re Application

Inventor(s): Fan ZHONG and Jonathan G. BORNSTEIN

Serial No.: 09/874,434

Filed: 6/4/01

Title: HIGH-DENSITY PLASMA DEPOSITION PROCESS FOR FABRICATING A TOP CLAD FOR PLANAR LIGHTWAVE CIRCUIT DEVICES

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

NOTIFICATION OF FILING OF CONTINUATION APPLICATION CLAIMING  
BENEFIT OF FILING DATE  
(THIS IS NOT A REQUEST FOR A CPA FILING)

☒ Notification is hereby being made of the filing of a continuation application claiming benefit for filing date for this case


☒ concurrently herewith.  
☐ on .....

Please direct all correspondence concerning the above-identified application to the following address:

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Respectfully submitted,

Date: December 16, 2003

By:   
Glenn D. Barnes  
Reg. No. 42,293